



# PULSED LASER DEPOSITION OF BIOACTIVE GLASS FILMS IN AMMONIA AND DISILANE ATMOSPHERES

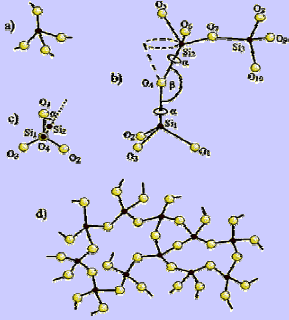
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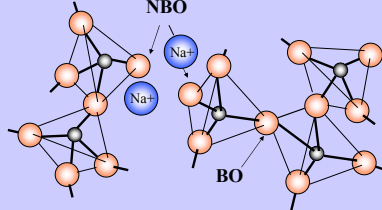
## AIM

To study the influence of  $\text{Si}_2\text{H}_6/\text{Ar}$  and  $\text{NH}_3/\text{Ar}$  atmospheres, with different pressure ranges, on the properties of silica-based bioactive glass coatings produced by Pulsed Laser Deposition (PLD)

### MATERIAL: BIOACTIVE GLASS

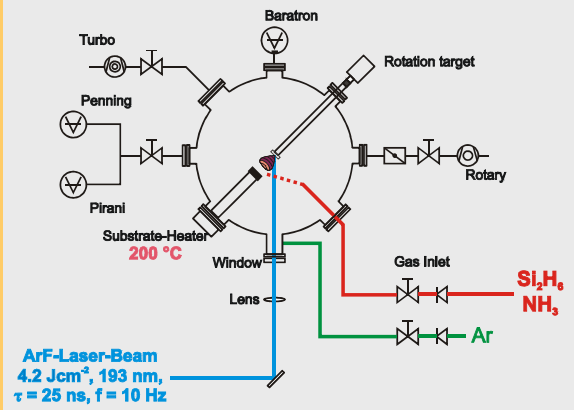


The bioactive silica-based glasses present an open amorphous network which structural unit consists on slightly distorted  $\text{SiO}_4$  tetrahedra.



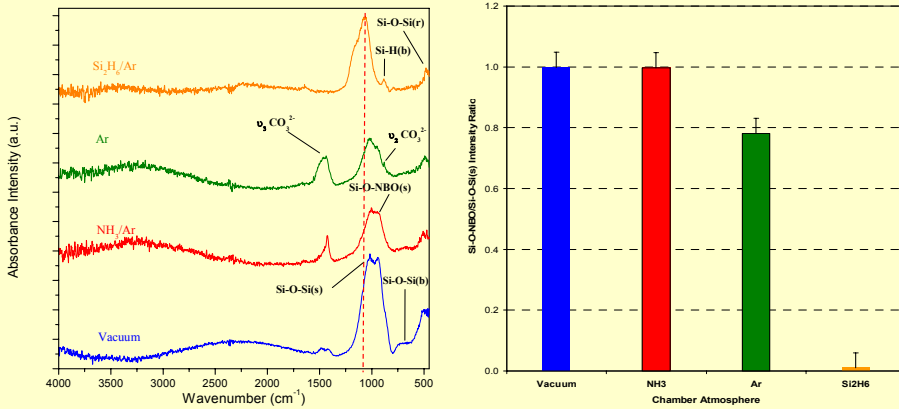
- Accommodation of network modifiers (alkali and alkali-earth cations) provokes disruption of the glassy network.
- Bridging oxygen (BO): oxygen atoms covalently bonded to a silicon neighbour.
- Non-bridging oxygen (NBO): oxygen being linked to a modifier cation.
- The arrangement and total amounts of NBO and BO groups determines bioactive performance.

### METHOD: Reactive PLD



## RESULTS

### Influence of the Atmosphere Type



Typical absorption bands for bioactive glasses have been identified:

- Si-O-Si(s) stretching mode in the range  $1000\text{-}1200\text{ cm}^{-1}$ .
- Si-O-NBO between  $890\text{-}950\text{ cm}^{-1}$ .
- Si-O-Si(b) bending mode located around  $760\text{ cm}^{-1}$ .
- Si-O-Si(r) rocking mode around  $500\text{ cm}^{-1}$ .

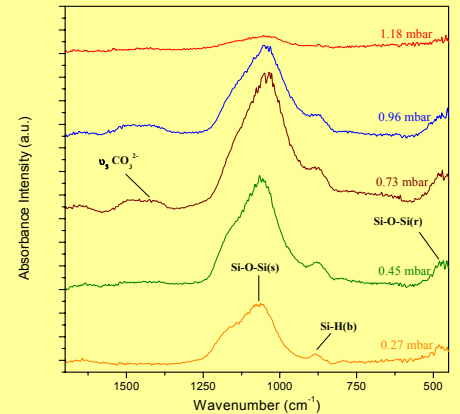
For **Ar** and **NH<sub>3</sub>/Ar** atmospheres the  $\text{CO}_3^{2-}$  band is enhanced.

For **Si<sub>2</sub>H<sub>6</sub>/Ar** atmosphere a Si-H(b) absorption band emerges.

Shift of the maximum absorbance of the Si-O-Si(s) band (-----) indicates a strained suboxide network, induced by the incorporation of network modifiers to the coating.

NBO groups in the coating are maintained for **NH<sub>3</sub>/Ar** ambient, reduced for **Ar** and suppressed for **Si<sub>2</sub>H<sub>6</sub>/Ar** atmosphere.

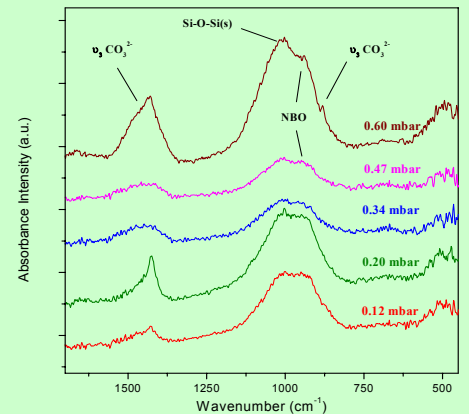
### Influence of Disilane Pressure



With  $\text{Si}_2\text{H}_6/\text{Ar}$  pressure increase:

- Slight incorporation of  $\text{CO}_3^{2-}$  groups to the coating
- The deposition rate is reduced.

### Influence of Ammonia Pressure



For  $\text{NH}_3/\text{Ar}$  pressure increase:

- Presence of NBO groups remain constant except for high pressures.

## CONCLUSION

The type of the reactive atmosphere in the surroundings of the plasma plume clearly affects the bonding configuration of the resulting film.

Low pressure of ammonia/argon atmosphere is the optimum condition to obtain coatings with improved properties for bioactive applications, in terms of concentration of NBO groups.

